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List of Documents
Cited by Applicant

Attv.	Docket:	00-GR1-4	08
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Serial No.: 10/044,286

Filing Date: January 11, 2002

Applicant: Olivier MENUT et al.

Group: 281

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Examiner: Date Considered: 8/15/e										
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conformance and not considered. Include copy of this form with next communication to applicant.										